

**LIST OF ART CITED BY APPLICANT**  
**(PTO-1449)**ATTY. DOCKET NO.  
**K-0624**APPLN. SERIAL NO.  
**10/804,236**APPLICANT(S)  
**Jin Woong KIM et al.**FILING DATE  
**March 19, 2004**GROUP  
**1746****U.S. PATENT DOCUMENTS**

EXAMINER'S INITIALS	*PATENT NO.	*ISSUE DATE	*INVENTOR NAME	CLASS	SUBCLASS	FILING DATE
/JLP/	2,296,257	09/1942	Breckenridge			
/JLP/	5,289,703	03/1994	Hiyashi et al.			
/JLP/	6,463,767	10/2002	Uzkureit et al.			

**U.S. PATENT APPLICATION PUBLICATIONS**

	*PATENT APPLN. PUB. NO.	*PUB. DATE	*APPLICANT	CLASS	SUBCLASS	
/JLP/	2002/0083743	07/2002	Uzbekit et al.			
/JLP/	2004/0123634	07/2004	Kim et al.			

**U.S. PATENT APPLICATIONS**

	*APPLN. NO.	*FILING DATE	*INVENTOR	CLASS	SUBCLASS	

**FOREIGN PATENT DOCUMENTS**

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
/JLP/	FR 1136981	05/1957	France				
/JLP/	FR 1580849	09/1969	France				
/JLP/	JP 10235075	09/1998	Japan				
/JLP/	EP 1350880	10/2003	Europe				

**OTHER ART (Including Author, Title, Date, Pertinent Pages, Publisher, Place of Publication, Etc.)**


EXAMINER

/Joseph L. Perrin/

DATE CONSIDERED

06/28/2007

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

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